

PATENT ASSIGNMENT COVER SHEET

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 Stylesheet Version v1.2

EPAS ID: PAT3482542

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT RESULTING FROM CORPORATE SPLIT
CONVEYING PARTY DATA	
Name	Execution Date
HITACHI METALS, LTD.	07/13/2015
RECEIVING PARTY DATA	
Name:	SCIOCS COMPANY LIMITED
Street Address:	880 ISAGOZAWA-CHO
Internal Address:	HITACHI-SHI
City:	IBARAKI-KEN
State/Country:	JAPAN
Postal Code:	319-1418
PROPERTY NUMBERS Total: 1	
Property Type	Number
Patent Number:	7097920
CORRESPONDENCE DATA	
Fax Number:	(520)882-7643
<i>Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.</i>	
Phone:	520-882-7623
Email:	cgee@hayes-soloway.com
Correspondent Name:	NORMAN P. SOLOWAY
Address Line 1:	4640 E. SKYLINE DRIVE
Address Line 4:	TUCSON, ARIZONA 85718
ATTORNEY DOCKET NUMBER:	NEC03P005
NAME OF SUBMITTER:	NORMAN P. SOLOWAY
SIGNATURE:	/norman p. soloway/
DATE SIGNED:	08/13/2015
Total Attachments: 2	
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source=Assignment#page2.tif	

ASSIGNMENT RESULTING FROM CORPORATE SPLIT

Hitachi Metals, Ltd., a Japanese Company, has filed for a corporate split from Sciocs company Limited, a Japanese company on April 1, 2015 and recorded with the Japanese Commercial Registry on April 15, 2015 under Item 26 of Article 2 of the Japanese Companies Act.

As a result of the corporate split, and in consideration of the payment by ASSIGNEE to ASSIGNOR of the sum of \$1 the receipt of which is hereby acknowledged, and for other good and valuable consideration, HITACHI METALS, LTD. Of 2-1, SHIBAURA, 1-CHOME MINATO-KU, TOKYO, JAPAN, an assignment previously Recorded on: December 30, 2014, under reel:034603, frame: 0912, hereby sells, assigns and transfers to SCIOCS COMPANY LIMITED of 880 ISAGOZAWA-CHO, HITACHI-SHI, IBARAKI-KEN, 319-1418 JAPAN and the successors, assigns and legal representatives of the ASSIGNEE, the entire right, title and interest, including right to sue for past infringement for the United States and its territorial possessions in and to any and all improvements which are disclosed in the invention entitled: GROUP III NITRIDE BASED SEMICONDUCTOR SUBSTRATE AND PROCESS FOR MANUFACTURE THEREOF, Name of inventor(s): USUI, AKIRA; SHIBATA, MASATOMO; and OSHIMA, YUICHI, and which is found in U.S. patent No: 7,097,920 issued: August 29, 2006 and, in and to, all Letters Patent to be obtained for said invention by the above application or any continuation, division, renewal, or substitute thereof, and as to letters patent any reissue or re-examination thereof;

ASSIGNOR hereby covenants that no assignment, sale, agreement or encumbrance has been or will be made or entered into which would conflict with this assignment;

ASSIGNOR further covenants that ASSIGNEE will, upon its request, be provided promptly with all pertinent facts and documents relating to said invention and said Letters Patent and legal equivalents as may be known and accessible to ASSIGNOR and will testify as to the same in any interference, litigation or proceeding related thereto and will promptly execute and deliver to ASSIGNEE or its legal representatives any and all papers, instruments or affidavits required to apply for, obtain, maintain, issue and enforce said application, said invention and said Letters Patent and said equivalents thereof which may be necessary or desirable to carry out the purposes thereof.

IN WITNESS WHEREOF, I/We have hereunto set hand and seal this 13th
day of July, 2015
(date of signing)

Warning: The date of signing must be the same as the date of execution of the application if item (a) was checked above.

Signature(s) of ASSIGNOR(S):

Date: July 13, 2015



(if ASSIGNOR is a legal entity, complete the following information)

Nobuyuki Hanafusa
(type or print the name of the above person authorized
to sign on behalf of ASSIGNOR)

General Manager, Intellectual Property Office

Title

Witness: 
Takahiro SAITO

Witness: 
Satoru MANO

Date: July 13, 2015

Date: July 13, 2015